

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		10/653,756	ALVA ET AL.	
Examiner		Art Unit		Page 1 of 1
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2005/0268162	12-2005	Milligan et al.	714/007
*	B	US-2005/0078195	04-2005	VanWagner, Craig K.	348/231.3
*	C	US-2004/0180692	09-2004	Yang et al.	455/557
*	D	US-2004/0030820	02-2004	Lan, Ching-I	710/300
*	E	US-6,980,465	12-2005	Taussig et al.	365/158
*	F	US-6,842,335	01-2005	Hanson et al.	361/683
*	G	US-6,817,531	11-2004	Taussig et al.	235/492
*	H	US-6,741,934	05-2004	Chen et al.	701/213
*	I	US-6,993,601	01-2006	Minami et al.	710/38
*	J	US-6,984,152	01-2006	Mowery et al.	439/638
*	K	US-6,776,348	08-2004	Liu et al.	235/492
*	L	US-6,385,677	05-2002	Yao, Li-Ho	711/115
*	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	EP1049325	11-2000		WEISSIG, CHRISTIAN	
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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